

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87054

Yasuki KIMURA

Appln. No.: 10/529,152

Group Art Unit: 1763

Confirmation No.: 1832

Examiner: Allan W. Olsen

Filed: March 24, 2005

For: METHOD OF ETCHING CHROMIUM THIN FILM AND METHOD OF PRODUCING
PHOTOMASK

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment dated September 10, 2008,
please amend the above-identified application as follows on the accompanying pages.